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Dated: December 12, 2008

Electronic Signature for Amy Hagan: /Amy Hagan/

Docket No.: 0042697.00149US3  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Roy G. GORDON et al. Confirmation No.: 7410  
Application No.: 10/534,687 Art Unit: 1621  
Filed: May 12, 2005 Examiner: G. P. Nazario  
Title: ATOMIC LAYER DEPOSITION USING METAL AMIDINATES

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated November 12, 2008, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.